

FIG.1

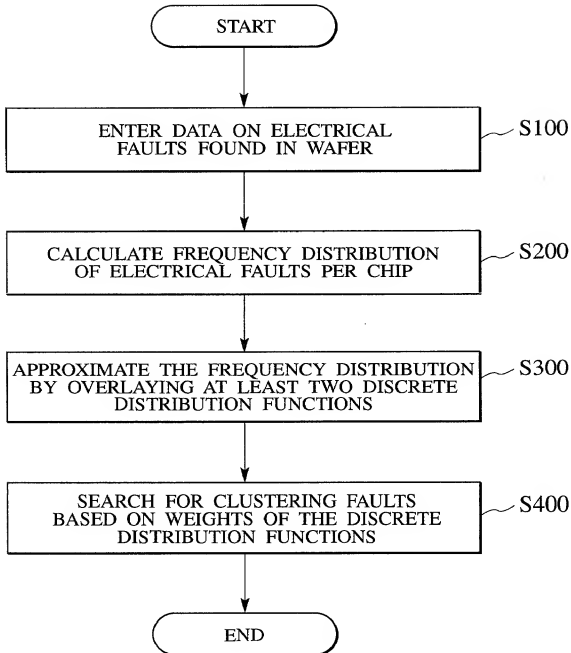


FIG.2

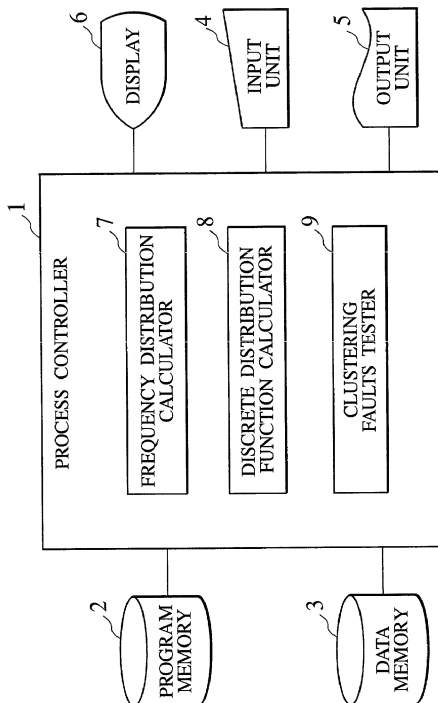


FIG.3

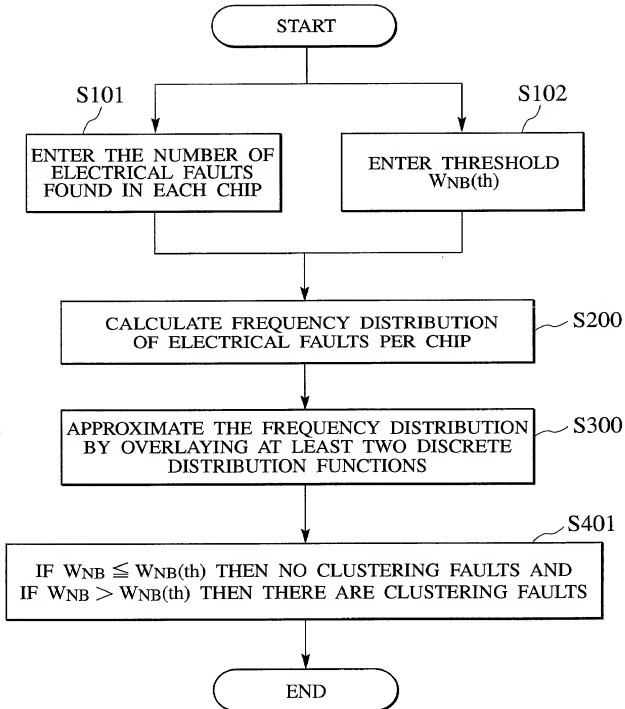


FIG.4A

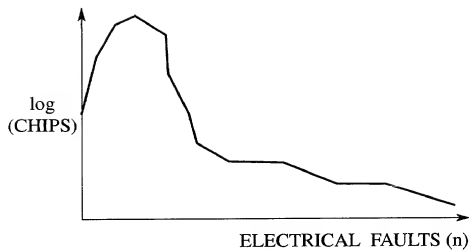


FIG.4B

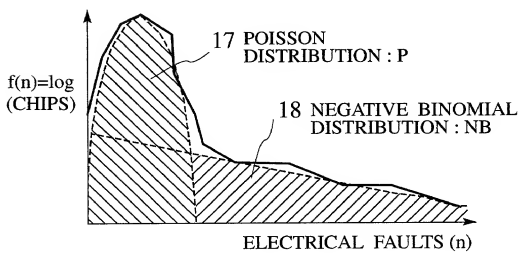


FIG. 6

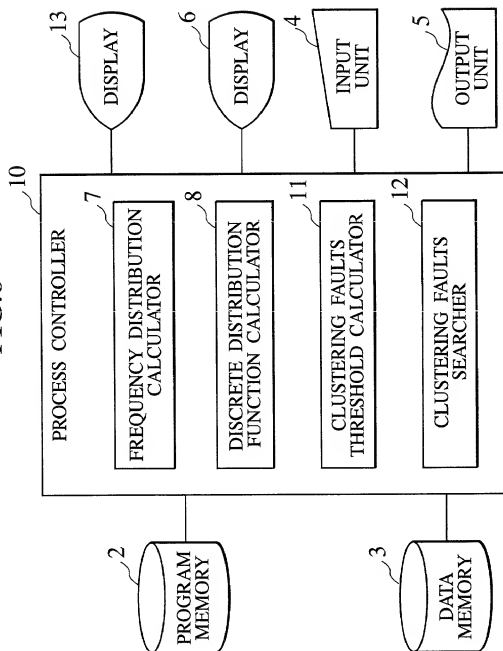
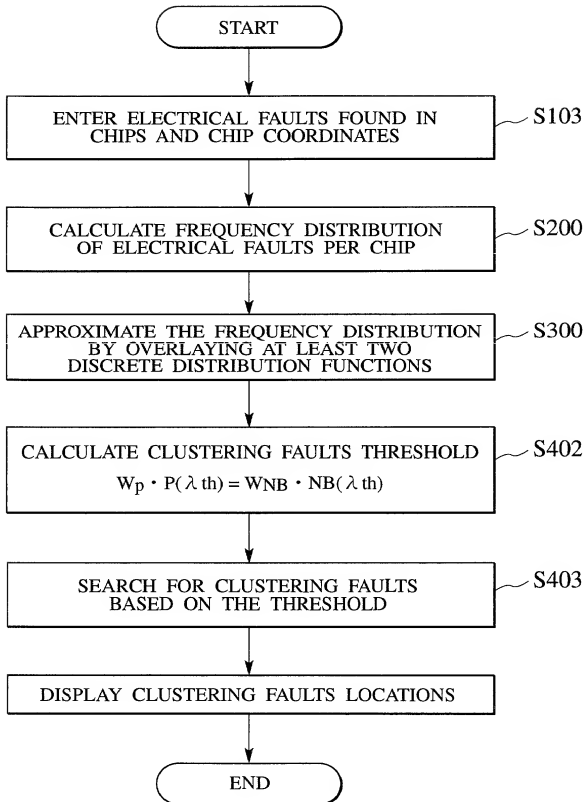


FIG. 7



8/24

FIG.8A

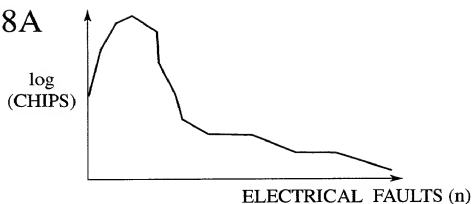


FIG.8B

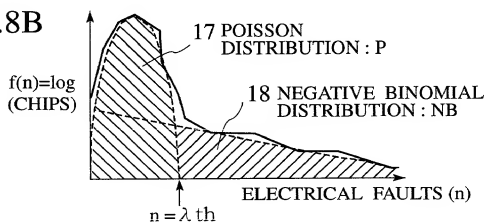


FIG.8C

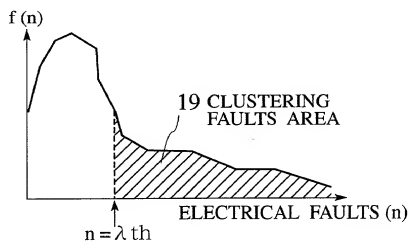


FIG.8D

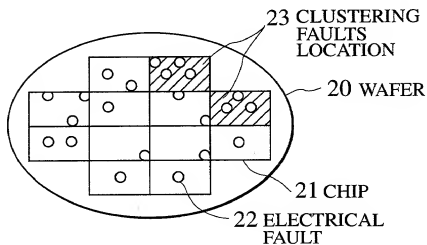
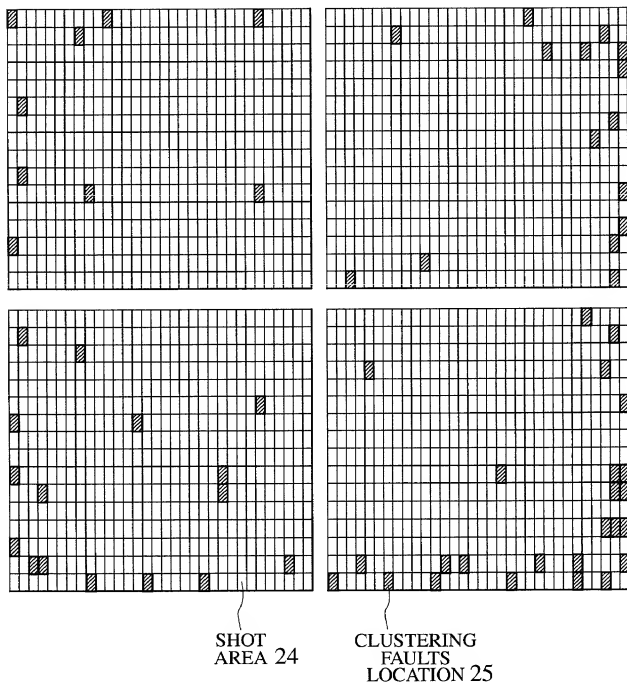


FIG.9



10/24

FIG.10

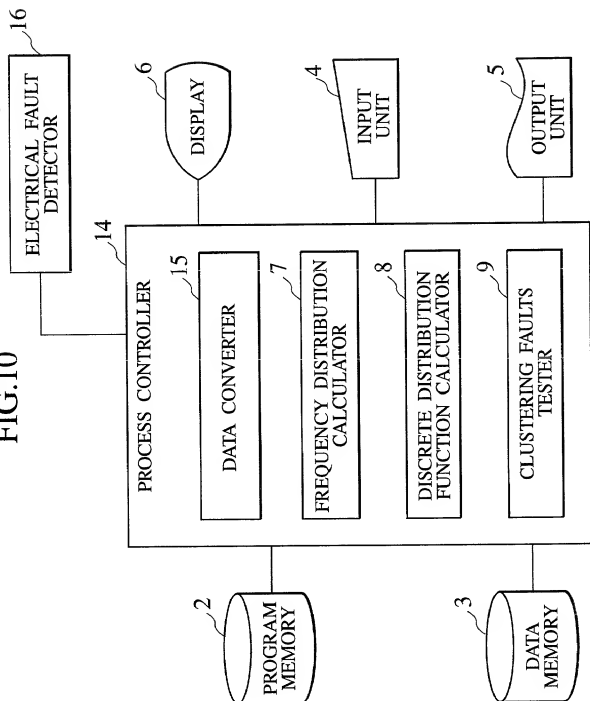


FIG.11

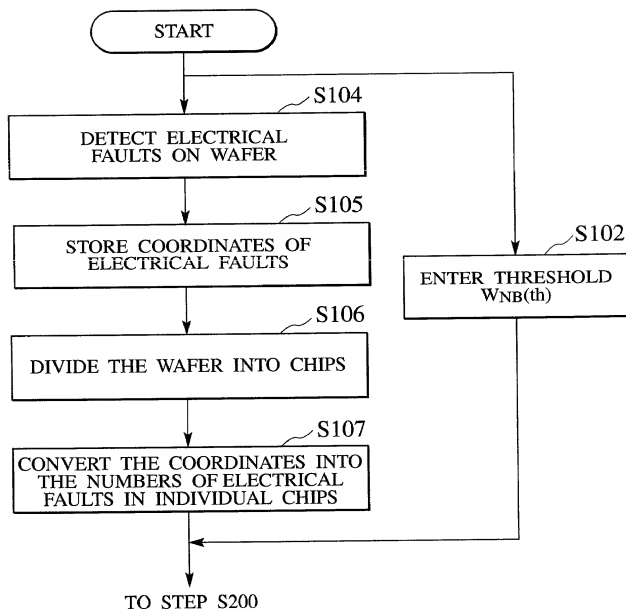


FIG.12

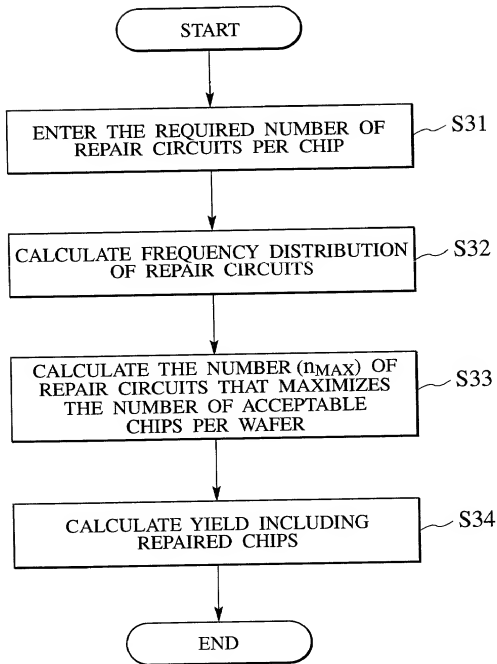


FIG.13A

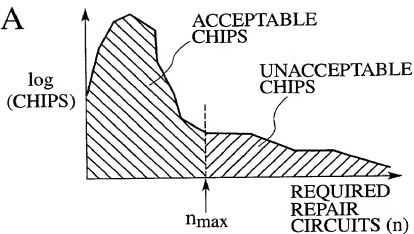


FIG.13B

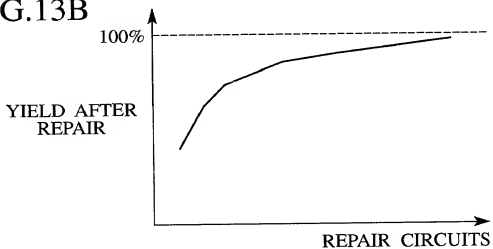


FIG.13C

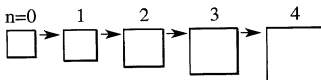


FIG.13D

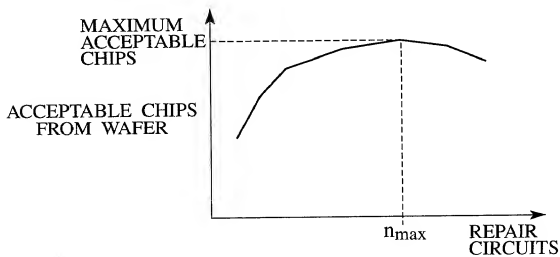


FIG.14

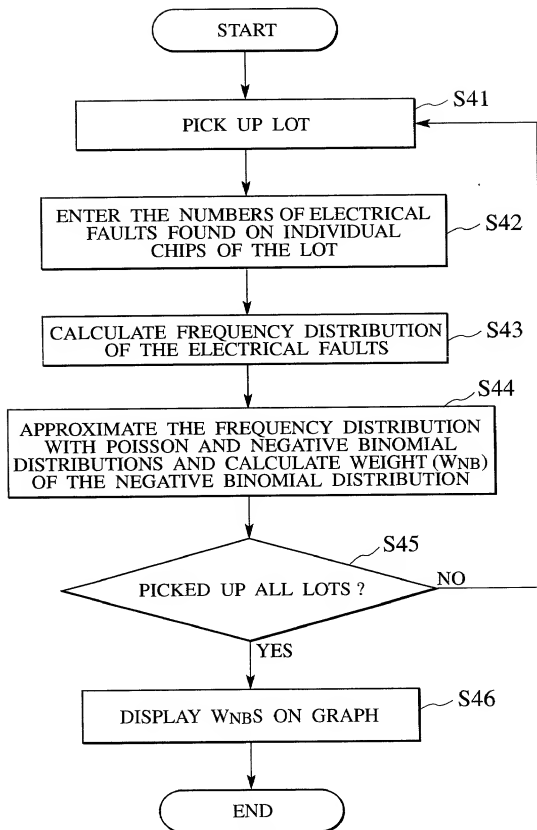


FIG.15

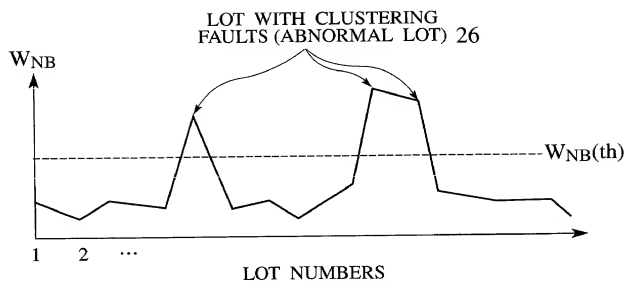


FIG.16

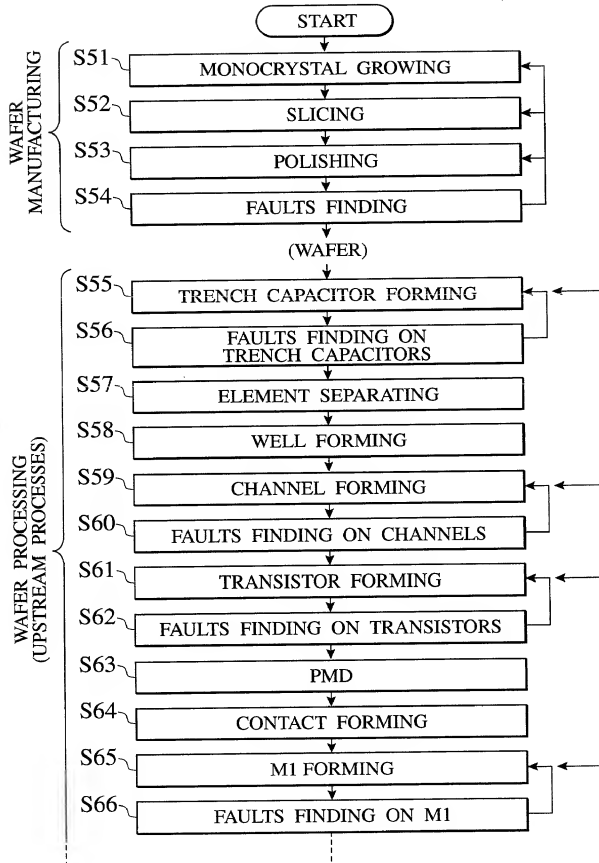


FIG.17

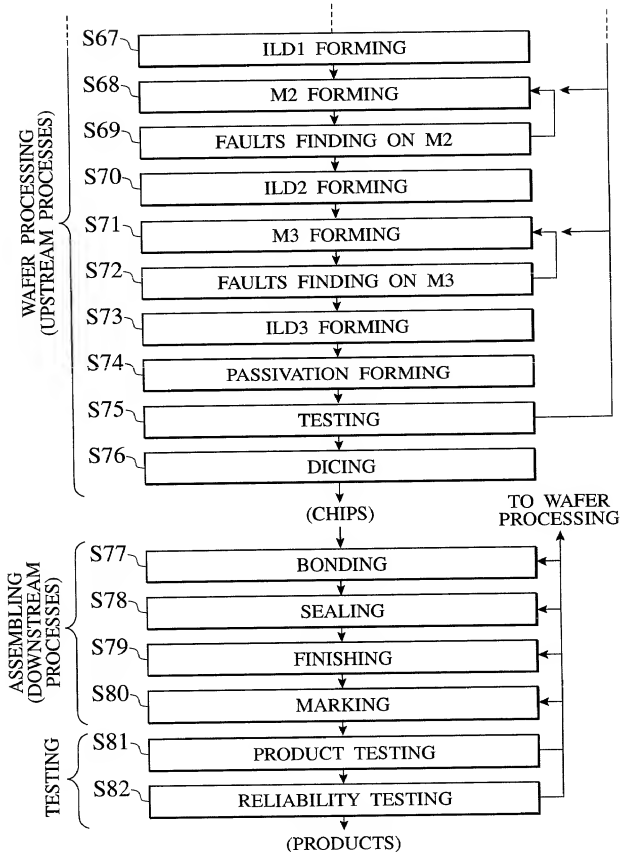
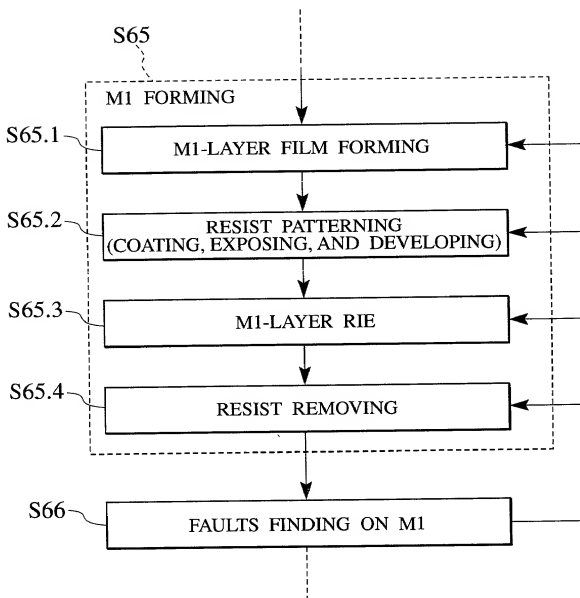


FIG.18



START



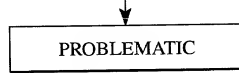
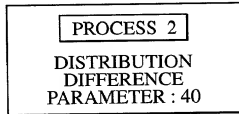
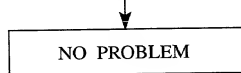
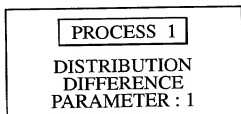
TO S93 OF FIG.20

FIG.20

FROM S92 OF FIG.19

S93

CALCULATE W_{NB} FREQUENCY DISTRIBUTION DIFFERENCE
BETWEEN EQUIPMENT FOR EACH PROCESS



S94

SEQUENTIALLY PICK UP PROCESSES AND EQUIPMENT OF
LARGE W_{NB} FREQUENCY DISTRIBUTION DIFFERENCES

30

	PROBLEMATIC PROCESS	PROBLEMATIC EQUIPMENT	DISTRIBUTION DIFFERENCE PARAMETER
1.	PROCESS 2	EQUIPMENT 2b	40
2.	PROCESS 6	EQUIPMENT 6c	15

END

FIG.21

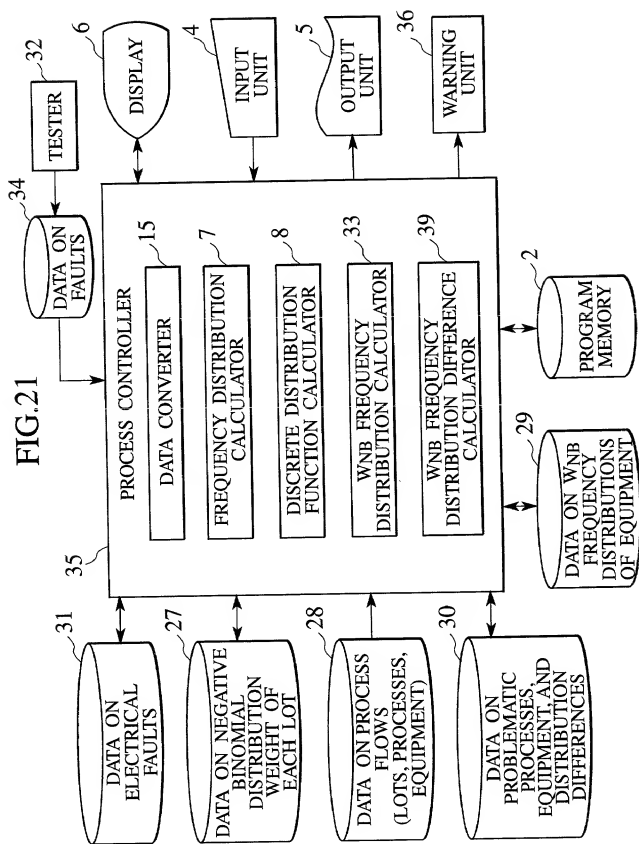


FIG.22

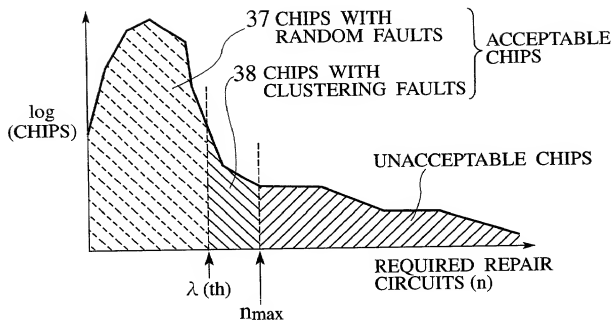


FIG.23

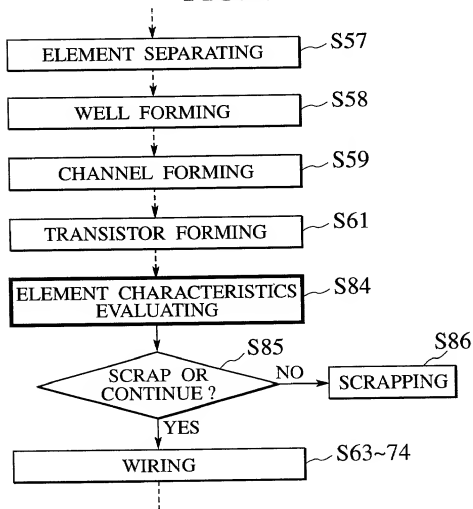


FIG.24

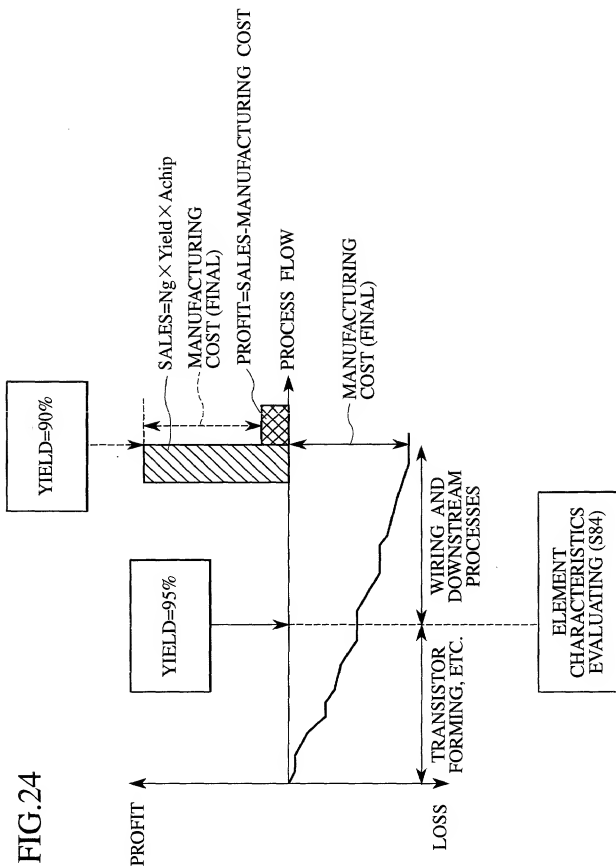


FIG.25A

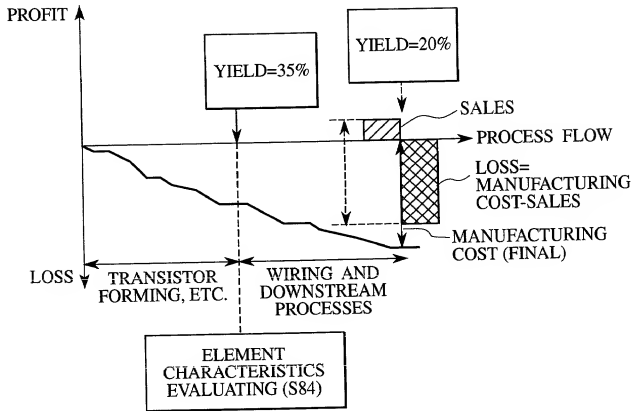


FIG.25B

